



ACTOPII 4th Workshop on Adaptive and Active X-ray & XUV Optics



FERMI@Elettra Free Electron Laser: First commissioning results and active optics project

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The PADReS team C. Fava S. Gerusina R. Gobessi L. Rumiz C. Svetina **M. Zangrando** 111 TR.L I. Cudin E. Mazzucco F. Debiasi 4th – 5th April 20 Diamond Light Source, Oxfordshire, UK



The Fermi project





















QuickTime™ e un decompressore sono necessari per visualizzare quest'immagine.

Courtesy by E. Allaria, W. Fawley



 4^{th} - $5^{th}\,$ April 2011, Diamond Light Source, UK





6 Runs of beam already performed Run 6 finished yesterday

4 (1-4) runs dedicated to Linac 1 run dedicated to Linac + Undulator (oct-dec 2010) (last week of run 5 dedicated to photon transport) last day of run 5 the first HHG seed FEL radiation spectra collected 1 run (run 6) dedicated to FEL generation and characterization Last days dedicated to the first experiments.















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Intensity Monitors







on the atomic photo-ionization are gas at low particle density (Neon, Xenon or Nitrogen)

MAIN FEATURES

• ULTRA-WIDE INPUT CURRENT RANGE

(from ± 140 fA up to ± 10 mA)

- 1, 2, 4-CHANNEL MONITORING
- MULTIRESOLUTION
- o 16-BIT MODE
- o 24-BIT MODE
- LOW NOISE (3 ppm of Full Scale)
- LOW DRIFT (3 ppm/° C)

Reading current, it is possible to derive the absolute number of photons per pulse shot-by-shot

24-Bit, 40 ksample/s, 4-Channel, Low Noise, Wide Dynamic Range

eam

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Intensity Monitors





Applied Voltage (Bias) + or - depending on tests/noise



Intensity Monitors calibration





Triggered Photodiode measured via an oscilloscope



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Intensity Monitors calibration





Triggered GMD measured via an oscilloscope DESY team march 2011 (Susanne Bonfigt, Barbara Keitel, Henning Kuehn, Michael Markert, Andrey Sorokin, Kai Tiedtke Svea Kapitzki Juray Krenpaski.)

Measured Intensity 10^11 ph/pulse at 65 nm.



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aelettra PADReS optical transport system & diagnostic



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Measured HGHG Seeded-FEL spectrum





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500

65 nm

300

1000

sigma=19 pixels = 21 meV

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Measured HGHG Seeded-FEL spectrum







Toward the experimental stations





General requirements

- LDM
 - Spot as small as possible with variable dimension from fully unfocused to few (as few as possible) microns size. Wavefront and coherence preservation. Maximize the fluence
- DIPROI
 - Spot as small as possible (micron size) with the possibility to use 70 e plates (0.5X0.5 mm² spot dimension). Wavefront and coherence preservation. Maximize the formula 100 mce
- TIMEX (have you attended the Svetina's talk?) "fixed" focus dimension ress than 10 μm possibly) with spot profile control (wavelength and experiment dependent). Maximize the fluence

Wavefront/choerence preservation means at Fermi shape errors below 5-7 nm P-V

Starting conditions

Beam divergence (diffraction limited) from 100 μ rad rms @ 80 nm to 5 μ rad rms @ 4 nm. Beam dimension after 80 m > 20 mm FWHM

Source sizes: 290 μ m FWHM for FEL 1, 140 μ m FWHM for FEL 2

Source distance variable as a function of electron beam energy, photon energy and FEL used.



Hosted by:

AC

Active optics project at Fermi



An R&D project started in late 2006 after first "future users meeting"

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FABRICATION, AND METROLOGY

INTERNATIONAL WORKSHOP ON X-RAY MIRROR DESIGN,

The first working prototype, using piezo patches was ready in the summer of 2009

October 9-11 2008, Trieste Italy

FERMI

Tuesday 22nd September - Thursday 24th September 2009 Osaka University, Suita, Osaka, Japan

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Integrated manpower dedicated ~ 5 months

Supported by:

That's was not good enough for our tight requirement but usable. A solution was found and, at the end we developed 3 different (even if similar) adaptive mirrors.





Hard X-ray Version





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Spot shaping mirror

Mirror dimension

Length 400 mm (possible from 250 to 600 mm) Useful 380 mm Width 40 mm (possible from 35 to 50 mm) Useful 20 mm

Possible shape obtainable:

Spherical shapes: From Flat ($R=^{\circ}$) to R = 60 m (on the 400 mm long mirror). Lower radius can be achieved with extra cost (strongest motors)

Asymmetry up to 1 μ m P-V equivalent to any ellipsoidal mirror with minimum focal distance of 1.2-1.4 m at 0.3 \Box grazing angle of incidence.

Shape error below 5 nm P-V, slope errors below 0.5 μrad rms. Roughness below 0.2 nm rms.

Minimum controllable mirror deformation: 0.5 nm on 4 cm spatial period. UHV compatibility down to low 10^{-8} mbar

It can be provided with a cooling system adopting copper braids. Maximum power

removable 15 W.

Bake out up to $120\Box$ feasible.

Anti twist system to avoid distortions in the orthogonal (sagittal) direction















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Some "small" thing to be considered:

•Great care on the gluing of the stainless still stripes.

•Proper dimensioning of the stripes (thickness and width) to avoid large stroke

•Proper rolling procedure of the stripes to balance minimum ad maximum correction amplitude.

Glue must be UHV compatible, beakebale, resistant but still flexible (non vitrifying one)
Proper dimensioning of the lateral support and motor (stronger force at the edges need stronger local corrections)

•.....

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Cost per mirror (as shown in picture) < 25k€

Should be operative in July 2011!

Mirror dimension

Length 400 mm (possible from 250 to 600 mm) Useful 380 mm Width 40 mm (possible from 35 to 50 mm) Useful 20 mm

Possible shape obtainable:

Spherical shapes: From Flat ($R=^{\circ}$) to R = 40 m (on the 400 mm long mirror). Lower radius can be achieved with extra cost (strongest motors)

Asymmetry up to 14 µm P-V equivalent to any ellipsoidal mirror with minimum focal distance of 1.2 m at 2 grazing angle of incidence or 0.8 m at 1 (shorter focal distances for larger angles of incidence can be achieved at extra costs) Shape error below 10 nm P-V, slope errors below 0.5 µrad rms. Roughness below 0.3 nm rms. Smaller values can be achieved. To be discussed Minimum controllable mirror deformation: 2 nm on 8 cm spatial period. UHV compatibility down to low 10⁻⁸ mbar It can be provided with a cooling system adopting copper braids. Maximum power removable 15 W. Bake out up to $120\Box$ feasible.

Anti twist system to avoid distorsion in the orthogonal (sagittal) direction





Conclusions

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D. Baron F. Debiasi

R. Sergo M. Cautero G. Sostero

M. Pellizzo J. Krempasky

F. Barbo L. Bella

We have a Seeded FEL working (first ever S-FEL spectra measurement performed) We need to improve it but we are on the right way We have a tested prototype for the KB mirror satisfying the requirement

Final mirror will be characterized on may, installed on June, operative on July!!! The DESY team sono necessari ce ruis nalizzare o nest immao ine 50 more meters of Photon transport system, 40 actuators, 5 University of Camerino University of Padua mirrors, 1.5 km of cables and few other stuff to be installed and tested within june

Next machine run will start on may 14. If someone wish to take part of the commissioning.... she/he is welcome (there are several night shifts to be assigned...)

Thank a lot and see You soon in Barcelona!

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